

10/658,107

FORM PTO-1449		Docket Number (Optional) 81872.0053		Application Number <u>Not assigned</u>		
INFORMATION DISCLOSURE CITATION IN AN APPLICATION		Applicant Yasuhiko SHIMOTSUMA et al.				
(Use several sheets if necessary)		Filing Date September 9, 2003		Group Art Unit <u>2883</u> <u>Not assigned</u>		
U.S. PATENT DOCUMENTS						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
FOREIGN PATENT DOCUMENTS						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
BMT	2000-193823	07/14/00	Japan	385	37X	Abstract
BMT	2001-066428	03/16/01	Japan	385	37X	Abstract
BMT	2001-004817	01/12/01	Japan	385	37X	Abstract
BMT	10-282337	10/23/98	Japan	385	37X	Abstract
BMT	11-352327	12/24/99	Japan	385	37X	Abstract
BMT	11-167024	06/22/99	Japan	385	37X	Abstract
BMT	2001-083321	03/30/01	Japan	385	37X	Abstract
BMT	2002-311242	10/23/02	Japan	385	37X	Abstract
BMT	2003-066232	03/05/03	Japan	385	37X	Abstract
BMT	2003-057442	02/26/03	Japan	385	37X	Abstract
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
BMT	Toshiaki KONDO et al., "Femtosecond Laser Interference Technique with Diffractive Beam Splitter for Fabrication of Three-Dimensional Photonic Crystal", Applied Physics Letters, Vol. 79, No. 6, August 6, 2001, pp. 725-727.					
BMT	Ken-ichi Kawamura et al., "Holographic Encoding of Fine-Pitched Micrograting Structures in Amorphous SiO ₂ Thin Films on Silicon by a Single Femtosecond Laser Pulse", Applied Physics Letters, Vol. 78, No. 8, February 19, 2001 pp.1038-1040					
EXAMINER	B. Healy		DATE CONSIDERED 4/11/07			
EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.						